



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

Report verification at igi.org

September 17, 2026	
IGI Report Number	
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	9.81 X 7.00 X 5.03 MM

GRADING RESULTS

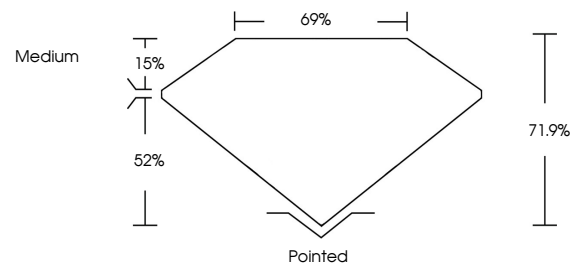
Carat Weight	3.00 CARATS
Color Grade	D
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

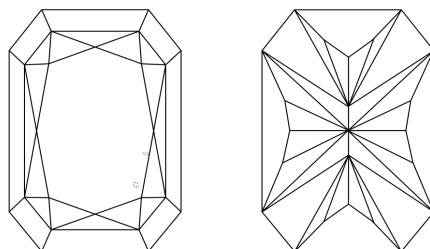
Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	131

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



September 17, 2026

IGI Report Number

Description **LABORATORY GROWN DIAMOND**

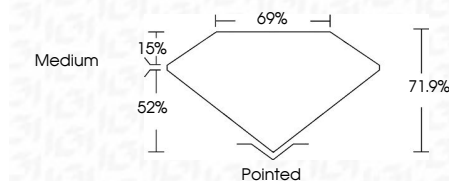
Shape and Cutting Style

Measurements **9.81 X 7.00 X 5.03 MM**

GRADING RESULTS

Carat Weight 3.00 CARATS

Color Grade

Clarity Grade WS 2

ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



© IGI 2020, International Gemological Institute

FD - 10 20

www.igi.org

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINE

September 17, 2026
 Final Report No
 CUT CONVERED RECT,
 0.81 X 7.00 X 5.03 MM,
 Color Weight
 Color Grade
 Clarity Grade
 Depth
 Table
 Girdle
 Culet
 Polish
 Symmetry
 Fluorescence
 Inscription(s)
 Comments:
 The Laboratory Growth
 Indicators (LGI) are
 reacted by Chemical
 Etching (CE) to reveal
 the (CVD) growth process
 and the internal
 features.